

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of: )  
Osamu ARISUMI ) Group Art Unit: 2814  
Application No. 09/617,138 ) Examiner: John C. Ingham  
Filed: July 14, 2000 ) Confirmation No. 5704  
For: SEMICONDUCTOR DEVICE AND )  
ITS MANUFACTURING METHOD )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**RESPONSE TO RESTRICTION REQUIREMENT**

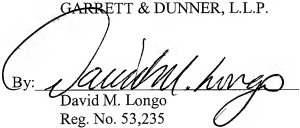
In a restriction requirement mailed January 24, 2008, the Examiner required restriction under 35 U.S.C. § 121 between Group I (claims 1-4 and 19-20), drawn to a semiconductor device, and Group II (claims 5-18), drawn to a manufacturing method. In response, Applicants elect to prosecute Group II, claims 5-18, without traverse.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW,  
GARRETT & DUNNER, L.L.P.

Dated: February 15, 2008

By:   
David M. Longo  
Reg. No. 53,235